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cladding layer.

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## THE CLAIMS

The following listing of claims replaces all prior versions and listings of claims in the above-referenced application:

1 1. (Currently amended) A device, comprising: 2 a growth surface; a growth mask on the growth surface, the growth mask defining an elongate 3 growth window; 4 an optical waveguide core mesa located in the growth window and having a 5 trapezoidal cross-sectional shape; 6 a sublayer formed on a surface of the optical waveguide core mesa that 7 opposes the growth surface; and 8 a cladding layer covering the sublayer and sidewalls of the optical waveguide 9 core mesa and extending over at least part of the growth mask, the cladding layer 10 comprising a plane major surface that is substantially parallel to the growth surface 11 and that extends over at least a part of the growth mask on each side of the growth 12 window; and 13 an electrode formed on the plane major surface of the cladding layer. 14 2. The device of claim 1, in which: (Original) 1 the growth surface has a [100] crystalline orientation; and 2 the optical waveguide core mesa comprises sidewalls having a [111] 3 crystalline orientation. 4 3. (Original) The device of claim 2, in which the growth mask 1 comprises opposed edges aligned parallel to the [011] crystalline direction of the 2 3 growth surface. The device of claim 1, in which the optical waveguide 1 4. (Original) core mesa is homogeneous in structure and has a greater refractive index than the 2

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- 5. (Original) The device of claim 1, in which: the device is an
- 2 optoelectronic device; and the optical waveguide core mesa comprises a quantum well
- 3 structure.
- 1 6. (Original) The device of claim 5, in which the quantum well
- 2 structure comprises quantum well layers comprising aluminum, gallium, indium and
- 3 arsenic.
- 7. (Original) The device of claim 5, in which the quantum well
- 2 structure comprises quantum well layers comprising gallium, indium, arsenic and
- 3 phosphorus.
- 8. (Original) The device of claim 5, in which the optical waveguide
  - core additionally comprises a separate confinement heterostructure in which the
- 3 quantum well structure is located.
- 1 9. (Original) The device of claim 5, in which the optical waveguide
- 2 core mesa comprises materials having a greater refractive index than the cladding
- 3 layer.

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- 1 10. (Original) The device of claim 1, in which: the cladding layer is a
- 2 first cladding layer; the device additionally comprises a second cladding layer; and the
- 3 growth surface is a surface of the second cladding layer.
- 1 11. (Original) The device of claim 1, in which the growth mask and
- 2 the optical waveguide core mesa are similar in thickness.
- 1 12.-22. (Canceled)